INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 26, 2024

IGI Report Number	LG653409256
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	7.92 - 7.94 X 4.85 MM

GRADING RESULTS

Carat Weight	1.86 CARAT
Color Grade	H
Clarity Grade	VS 1
Cut Grade	IDEAL

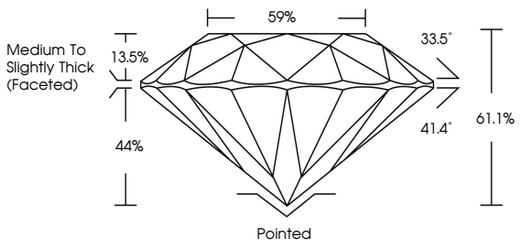
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG653409256

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG653409256
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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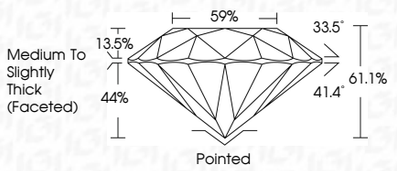
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IGI

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ROUND BRILLIANT
7.92 - 7.94 X 4.85 MM
Carat Weight 1.86 CARAT
Color Grade H
Clarity Grade VS 1
Cut Grade IDEAL
Depth 61.1%
Table 59%
Girdle Medium To Slightly Thick (Faceted)
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG653409256
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa